

*IN THE UNITED STATES PATENT AND TRADEMARK OFFICE*

In re PATENT APPLICATION of :  
Naokatsu Ikegami : Group Art Unit: 1765  
Application No. 10/698,546 : Examiner: Kin Chan Chen  
Filed: November 3, 2003 :

For: METHOD OF DRY ETCHING ORGANIC SOG FILM

---

**AMENDMENT ACCOMPANYING REQUEST  
FOR CONTINUED EXAMINATION**

U.S. Patent and Trademark Office  
**E-Filing**  
Randolph Building  
401 Dulany Street  
Alexandria VA 22314

Sir:

In response to the Office Action dated February 13, 2009, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.